

<b>Notice of References Cited</b>	Application/Control No. 10/728,185	Applicant(s)/Patent Under Reexamination HAUCK ET AL.	
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#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,680,755 A	07-1987	Reames, Stephen P.	370/451
*	B	US-5,495,481 A	02-1996	Duckwall, William S.	370/462
*	C	US-5,802,057 A	09-1998	Duckwall et al.	370/408
*	D	US-6,266,334 B1	07-2001	Duckwall, William	370/397
*	E	US-6,356,558 B1	03-2002	Hauck et al.	370/450
*	F	US-2003/0179719 A1	09-2003	KOBAYASHI et al.	370/282
*	G	US-2003/0202539 A1	10-2003	FUKUNAGA et al.	370/489
*	H	US-6,904,044 B2	06-2005	Duckwall et al.	370/408
*	I	US-2004/0246959	12-2004	Duckwall et al.	370/389
*	J	US-6,904,044	06-2005	Duckwall et al.	370/408
*	K	US-6,266,334	07-2001	Duckwall, William	370/397
*	L	US-4,680,755	07-1987	Reames, Stephen P.	370/451
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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